

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventive Application of:
Alain Duboust, et al.

Serial No.: 10/032,275

Confirmation No.: 4052

Filed: December 21, 2001

For: Electrolyte Composition
and Treatment For
Electrolytic Chemical
Mechanical Polishing

Group Art Unit: 1745

Examiner: Thomas H. Parsons

MAIL STOP
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 CFR 1.8

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Date

Robert D. Edwards
Signature

Dear Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/5998.

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. AMAT/5998/CMP/CMP /RKK		Serial No. 10/032,275	
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT				Applicant Duboust, et al.		Confirmation No.: 4052	
(Use several sheets if necessary)				Filing Date December 21, 2001		Group 1745	
Examiner Thomas H. Parsons							

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date if Appropriate
	A1	6,555,158 B1	04-29-2003	Yoshio, et al.	427	97	01-20-2000
	A2	6,355,153 B1	03-12-2002	Uzoh, et al.	205	87	09-17-1999
	A3	6,354,916 B1	03-12-2002	Uzoh, et al.	451	41	04-06-2000
	A4	2003/0104762 A1		Sato, et al.	451	9	11-26-2002
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
	A13						

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
	C3	

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.